PTO/SB/08 Equivalent 10/822,424 Application No. CARMATION DISCLOSURE April 12, 2004 Filing Date Bulent M. Basol et al. First Named Inventor STATEMENT BY APPLICANT 1709 1742 Art Unit Unknown Zulmariam Méndez Examiner (Multiple sheets used when necessary) NVLUS.029CPI SHEET 1 OF 1 Attorney Docket No.

	U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear			
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/ZM/ Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹

(7)	NON PATENT LITERATURE DOCUMENTS				
/ZM/ Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	. _T 1		

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Examiner Signature	/Zulmariam Mendez/	Date Considered	05/07/2007	

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٠		Application No.	10/822,424
6	I P ENFORMATION DISCLOSURE	Filing Date	April 12, 2004
1AR 0 1 2	STATEMENT BY APPLICANT	First Named Inventor	Bulent Basol, et al.
	OF ALEIVIENT DI AFFLICANT	Art Unit	H742 1709
	Multiple sheets used when necessary)	Examiner	Unknown /Zulmariam Mendez/
P	SHEET 1 OF 1	Attorney Docket No.	ASMNUT.029CP1
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Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear			
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/ZM/	2	US 2003/0223764	12/2003	Moore, et al.				
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INFORMATION DISCLOSURE ATEMENT BY APPLICANT

> (Multiple sheets used when necessary) SHEET 1 OF 4

	PTO/SB/08 Equivalent
Application No.	10/822,424
Filing Date	April 12, 2004
First Named Inventor	Basol et al.
Art Unit	1742 1709
Examiner	Unknown /Zulmariam Mendez/
Attorney Docket No.	ASMNUT.029CP1

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10/822,424 Application No. INFORMATION DISCLOSURE April 12, 2004 Filing Date First Named Inventor Basol et al. STATEMENT BY APPLICANT 1709 Art Unit 1742 /Zulmariam Mendez/ (Multiple sheets used when necessary) Examiner Unknown SHEET 2 OF 4 ASMNUT.029CP1 Attorney Docket No.

	U.S. PATENT DOCUMENTS						
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear		
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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SHEET 3 OF 4

	1 10/3B/06 Equivalent
Application No.	10/822,424
Filing Date	April 12, 2004
First Named Inventor	Basol et al.
Art Unit	1742 1709
Examiner	Unknown /Zulmariam Mendez/
Attorney Docket No.	ASMNUT.029CP1

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Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear		
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PTO/SB/08 Equivalent

	Application No.	10/822,424
INFORMATION DISCLOSURE	Filing Date	April 12, 2004
STATEMENT BY APPLICANT	First Named Inventor	Basol et al.
STATEMENT BY AFFEIGANT	Art Unit	1742 1709
(Multiple sheets used when necessary)	Examiner	Unknown /Zulmariam Mendez/
SHEET 4 OF 4	Attorney Docket No.	ASMNUT.029CP1

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